



00862.022183

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: I. Soward
Haruhito ONO et al.)	
	:	Group Art Unit: 2822
Application No.: 09/819,737)	
	:	Confirmation No.: 4343
Filed: March 29, 2001)	
	:	
For: ELECTROOPTIC SYSTEM ARRAY,)	
CHARGED-PARTICLE BEAM	:	May 6, 2004
EXPOSURE APPARATUS USING THE)	
SAME, AND DEVICE	:	
MANUFACTURING METHOD)	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to further examination on the merits, please amend the above-identified application
as follows: